

Docket No.: 063979-0028



IFM AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: NISHIKAWA, TAKASHI, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/616,917

Customer No.: 20277
Confirmation No.: 2411

Filed: July 11, 2003

Group Art Unit: 2822

Examiner: Kiesha L. Rose

Title: A SEMICONDUCTOR DEVICE AND A FABRICATION METHOD THEREOF

RESPONSE UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated July 27, 2005, having a three-month shortened statutory period for response set to expire October 27, 2005, reconsideration of the above-identified application is respectfully requested in view of the following remarks.